

Deprotection of Sulfonamides Using Iodotrimethylsilane

Gowravaram Sabitha,* B.V. Subba Reddy, Sunny Abraham and J.S. Yadav

Organic Division-I, Indian Institute of Chemical Technology, Hyderabad-500 007, India.

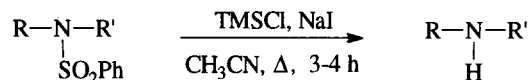
Received 28 August 1998; revised 9 December 1998; accepted 14 December 1998

Abstract : The deprotection of sulfonamides is achieved under neutral conditions by reaction with iodotrimethylsilane in acetonitrile at reflux. © 1999 Published by Elsevier Science Ltd. All rights reserved.

Keywords : Amines; Sulfonamides; Iodotrimethylsilane; Acetonitrile.

The protection of amines by sulfonyl groups is often used in organic synthesis [1], because the resultant sulfonamides are crystalline and more resistant to nucleophilic attack. Moreover, sulfonamides derived from primary amines can be easily deprotonated and the anions serve as nucleophiles in reactions with alkylating reagents [2]. Previously reported methods for deprotection required drastic conditions (lengthy reaction times, strongly basic conditions) [3] e.g sodium naphthalenide [4], sodium in liquid ammonia and refluxing in strong acid [5]. Therefore, there is much interest in the development of new deprotection methods which include SmI_2 [6], Mg in methanol [7] and TBAF [8].

In continuation of our work dealing with the reductive cleavage of phthalides [9], we now report a simple and mild deprotective method of sulfonamides using iodotrimethylsilane in acetonitrile. Iodotrimethylsilane is an extremely useful and versatile reagent in organic synthesis [10].



Scheme

The desulfonylation proceeds with 1.5 eq. of iodotrimethylsilane in acetonitrile, refluxing for 3-4 hr in good yields. The mild reaction conditions employed in this deprotection method allow the selective deprotection of sulfonamides in the presence of N-alkyl and N-benzyl groups. (For yields and conditions, see, table). However, the deprotection of secondary sulfonamides did not take place under similar conditions.

In conclusion, the reagent used for this cleavage is inexpensive, non-toxic and the cleavage is carried out under mild and neutral conditions.

IICT Communication No. 4129

* To whom correspondence be addressed

Table 1 Deprotection of Sulfonamides with Iodotrimethylsilane

Entry	Sulfonamide	Product ^a	Yield ^b (%)
1.			88
2.			86
3.			88
4.			86
5.			86
6.			88
7.			84
8.			84
9.			74
10.			76
11.			74
12.			70

a) All the products were characterised by IR and ¹HNMR. b) Isolated yields

In a typical procedure; to a suspension of sodium iodide (1.5 mmol) in acetonitrile (10 mL) chlorotrimethylsilane (1.5 mmol) was added dropwise and stirred for 10 minutes at 0°C under a N₂ atmosphere. To this stirred suspension, a solution of N,N-diphenylsulfonamide (1 mmol) in acetonitrile (5 mL) was added and refluxed for 3 hrs. The reaction mixture was quenched with water and extracted with ethylacetate (25 mL). The organic layer was washed with 10% sodium thiosulphate solution, brine, dried over anhydrous Na₂SO₄ and concentrated under vacuum to give the crude product. This was purified by column chromatography to afford pure N,N-diphenylamine (88% yield).

Acknowledgement : BVS and SA thank CSIR, New Delhi for the award of fellowship.

References

1. a) Greene, T.W.; Wuts, P.G.M. *Protective Groups in Organic Chemistry*, Wiley-Interscience, New York, 2nd edn., 1991.
b) Kocienski, P.J. *Protecting Groups*, Thieme, New York, 1994.
2. Henry, J.R.; Marcin, L.R.; McIntosh, M.C.; Scola, P.M.; Harris, G.D.; Weinreb, S.M. *Tetrahedron Lett.* **1989**, *30*, 5709.
3. a) Sundberg, R.J.; Laurino, J.P. *J. Org. Chem.* **1984**, *49*, 249.
b) Anderson, H.J.; Loader, C.E.; Xu, R.X.; Le, N.L.; Gogan, N.J.; McDonald, R.; Edwards, L.G. *Can. J. Chem.* **1985**, *63*, 896.
4. Gortler, S.J.L.B.; Waring, A.; Battisi, A.; Bame, S.; Closson, W.D.; Wriede, P. *J. Am. Chem. Soc.* **1967**, *89*, 5311.
5. Roemmele, R.C.; Rapaport, H. *J. Org. Chem.* **1988**, *53*, 2361 and references cited therein.
6. Knowles, H.; Parsons, A.F.; Peltifer, R.M. *Synlett* **1997**, 271.
7. Nyare, B.; Grehn, L.; Ragnarsson, U. *Chem. Comm.* **1997**, 1017.
8. Yasuhara, A.; Sakanoto, T. *Tetrahedron Lett.* **1998**, *39*, 595.
9. Sabitha, G.; Yadav, J.S. *Synth. Commun.* **1998**, *28*, 3065.
10. For a review, see: Olah, G.A.; Narang, S.C. *Tetrahedron* **1982**, *38*, 2225.